

Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
(Use as many sheets as necessary)



Sheet 1 of 1

Complete if Known

<b>Application Number</b>	09/945497
<b>Filing Date</b>	August 30, 2001
<b>First Named Inventor</b>	Sandhu, Gurtej
<b>Group Art Unit</b>	2822
<b>Examiner Name</b>	Rose, Kiesha

Attorney Docket No: 303.541US3

**US PATENT DOCUMENTS**

Examiner Initials*	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date If Appropriate
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Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	T <sup>2</sup>

**OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
KR		• KUHN, G , et al., "Thin Silicon Film on Insulating Substrate", <u>Journal of the Electrochemical Society</u> , 120(11), (1973), pp. 1563-1566	
KR		• SCHNAKENBERG, U , et al., "TMAHW Etchants for Silicon Micromachining", <u>Transducers - International Conference on Solid-State Sensors and Actuators - Digest of Technical Papers</u> , (1991), pp. 815-818	

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Substitute Disclosure Statement Form (PTO-1449)

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